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March 9, 2006

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Commissioner for Patents
PO Box 1450
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Art Unit 2831

Attn: Mail Stop Amendment

Re: U.S. Utility Patent Application
Application No. 10/813,200; Filed: March 29, 2004
For: **A Process for Manufacturing High-Stability Crystalline Anodic
Aluminum Oxide for Pulse Discharge Capacitors**
Inventors: Stevens *et al.*
Our Ref: A04P3005-US1 (1587.0790000/DRB/KPQ)

Sir:

Transmitted herewith for appropriate action are the following documents:

1. Reply Under 37 C.F.R. § 1.111; and
2. Return postcard.

It is respectfully requested that the attached postcard be stamped with the date of filing of these documents, and that it be returned to our courier. In the event that extensions of time are necessary to prevent abandonment of this patent application, then such extensions of time are hereby petitioned.

Commissioner for Patents
March 9, 2006
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The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

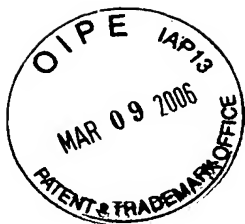
Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.



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DRB/KPQ:dms
Enclosures



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Stevens *et al.*

Appl. No.: 10/813,200

Filed: March 29, 2004

For: **A Process for Manufacturing High-Stability Crystalline Anodic Aluminum Oxide for Pulse Discharge Capacitors**

Confirmation No.: 5164

Art Unit: 2831

Examiner: Ha, Nguyen T.

Atty. Docket: A04P3005-US1
(1587.0790000/ DRB/KPQ)

Reply Under 37 C.F.R. § 1.111

Mail Stop Amendment

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated December 12, 2005, Applicants submit the following Remarks.

It is not believed that extensions of time or fees for net addition of claims are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 19-0036.